



AF/1763
ZFW

Attorney Docket No.: SEL 231

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Yamazaki et al.)
Serial No.: 09/724,002)
Filed: November 28, 2000)
For: Film Deposition Apparatus And)
Method Of Manufacturing A Light)
Emitting Device Using The)
Apparatus)
Art Unit: 1763)
Examiner: K. Moore)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited
with the United States Postal Service as first class mail in an
envelope addressed to:
Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on

September 13 2006
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 9/13/06
Signature Date

AMENDMENT H (AFTER FINAL)

Sir:

In response to the Final Rejection dated June 13, 2006, please enter the following
amendment in the above-identified application: